

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

First Named	Conf. No. 7978
Inventor : Benjamin Y.H. Liu	Group Art Unit: 1792
Appln. No.: 10/769,011	
Filed : January 30, 2004	
For : HIGH-PERFORMANCE AND MULTI-LIQUID-PERCURSOR VAPORIZATION IN SEMICONDUCTOR THIN FILM DEPOSITION	Examiner: Bueker, Richard R.
Docket No.: M419.12-0043	

REQUEST FOR APPROVAL OF FORMAL DRAWINGS

VIA ELECTRONIC FILING
DECEMBER 4, 2008

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450
Sir:

Enclosed are **EIGHT** (8) sheets of formal drawings for filing in the above-identified application.

Respectfully submitted,

WESTMAN, CHAMPLIN & KELLY, P.A.

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